IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

opplicant: and A. Farrar et al.

Docket No.:

BURIED CONDUCTORS

Docket No

303.367US3

Filed:

November 11, 2003

Examiner:

Unknown

Customer No.: 21186

Serial No.: 10/705185

Due Date: N/A

Group Art Unit: Unknown

Confirmation No.:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

X A return postcard.

An Supplemental Information Disclosure Statement (2 pgs.), Form 1449 (1 pg.), and copies of 7 cited documents.

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

Atty: Timothy B Clise Reg. No. 40,957

<u>CERTIFICATE UNDER 37 CFR 1.8:</u> The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O.Box 1450, Alexandria, VA 22313-1450, on this <u>1st</u> day of December 2003.

Name

Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

(GENERAL)





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Applicant: Paul A. Farrar et al.

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Title:

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Supplemental Information Disclosure Statement. However, if an Office Action on the merits has been mailed, the Commissioner is hereby authorized to charge the required fees to Deposit Account No. 19-0743 in order to have this Supplemental Information Disclosure Statement considered.

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

The present application is either a U.S. national patent application filed after June 30, 2003 or an international application that entered the national stage under 35 U.S.C. § 371 after June 30, 2003. Thus, Applicant believes that the U.S. Patent & Trademark Office has waived the requirement under 37 C.F.R. 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication. The waiver is provided in a pre-OG notice from the U.S. Patent & Trademark Office entitled "Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003" and dated July 11, 2003. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

Respectfully submitted,

PAUL A. FARRAR ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938
Minneapolis, MN 55402
(612) 349-9587

Date 1 Dec '03

Timothy B Clise Reg. No. 40,957

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Name Tina Wanut

Signature

Substitute for form 1449A/PTO
HAT ORMATION DISCLOSURE
STATEMENT BY APPLICANT
(Use as many sheets as necessary) PTO/SB/08A(10-01)
Approved for use through 10/3/12002, 2008 651-0031
US Patent & Trademerk Office: U.S. DEPARTMENT OF COMMERCE
(The Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known **Application Number** 10/705185 November 11, 2003 (Use as many sheets as necessary) Filing Date **First Named Inventor** Farrar, Paul **Group Art Unit** Unknown **Examiner Name** Unknown Attorney Docket No: 303.367US3 Sheet 1 of 1

US PATENT DOCUMENTS									
Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate			
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	US-4,670,297	06/02/1987	Lee, K., et al.	427	91	06/21/1985			
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Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T²	

	OTHER	R DOCUMENTS NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the No (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(publisher, city and/or country where published.		
	V	ABIDI, "Large Self-Suspended Inductors on Silicon and Their Use in 2-mu m CMOS RF Amplifier", <u>IEEE Electron Device Letters</u> , Vol. 17, No. 9, (1993),246-48	
	(BURGHARTZ, et al., "Integrated RF and Microwave Components in BiCMOS Technology", IEEE Trans. Electron Devices, Vol. 43, No. 9,(1996),1559-70	
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	V	MEYER, et al., "Si IC-Compatible Inductors and LC Passive Filters", <u>IEEE</u> Journal of Solid State Circuits, Vol. 25, No. 4, (1990),1028-31	
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	/	TING, C. H., "Methods and Needs for Low K Material Research", <u>Materials Research Society Symposium Proceedings</u> , <u>Volume 381</u> , Low-Dielectric Constant Materials Synthesis and Applications in Microelectronics, Lu, T.M., et al., (eds.), San Francisco, CA,(April 17-19, 1995),3-17	

EXAMINER DATE CONSIDERED